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High-Temperature Mechanical Properties of a DOP-26 Iridium Alloy under Impact Loading

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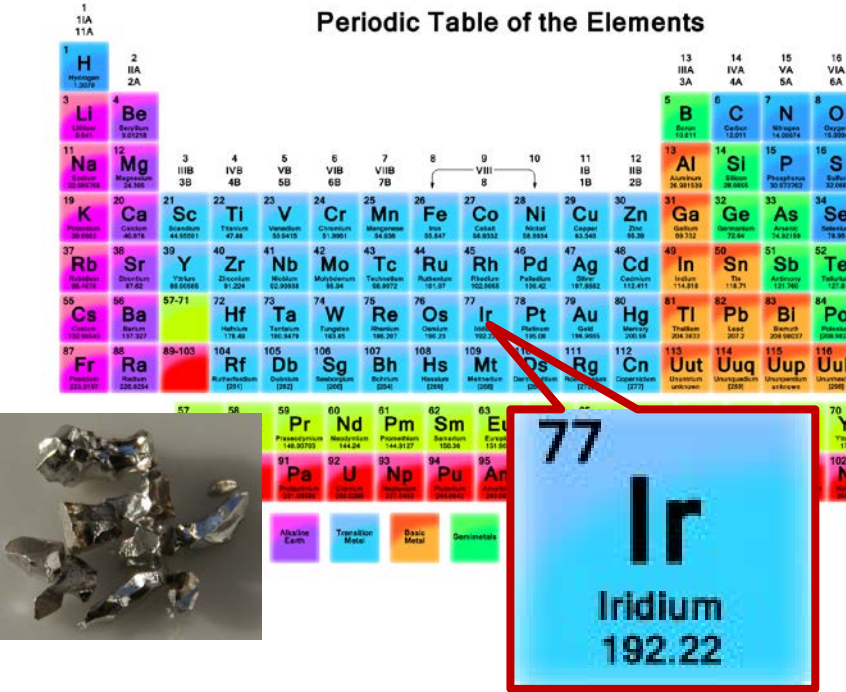



Outline

- **Background**
- **Kolsky bar techniques for dynamic characterization of materials**
 - High-temperature Kolsky compression bar technique
 - High-temperature Kolsky tension bar technique
- **Dynamic high-temperature characterization of iridium**
 - In compression
 - In tension
- **Experimental Results**
- **Summary**
- **Acknowledgments**

Background

Periodic Table of the Elements



Physical properties		Miscellanea	
Phase	solid	Crystal structure	face-centered cubic 
Density (near r.t.)	22.56 g·cm ⁻³	Magnetic ordering	paramagnetic ^[1]
Liquid density at m.p.	19 g·cm ⁻³	Electrical resistivity	(20 °C) 47.1 nΩ·m
Melting point	2739 K, 2466 °C, 4471 °F	Thermal conductivity	147 W·m ⁻¹ ·K ⁻¹
Boiling point	4701 K, 4428 °C, 8002 °F	Thermal expansion	6.4 μm/(m·K)
Heat of fusion	41.12 kJ·mol ⁻¹	Speed of sound (thin rod)	(20 °C) 4825 m·s ⁻¹
Heat of vaporization	563 kJ·mol ⁻¹	Young's modulus	528 GPa
Molar heat capacity	25.10 J·mol ⁻¹ ·K ⁻¹	Shear modulus	210 GPa
		Bulk modulus	320 GPa
		Poisson ratio	0.26
		Mohs hardness	6.5
		Vickers hardness	1760 MPa
		Brinell hardness	1670 MPa
		CAS registry number	7439-88-5

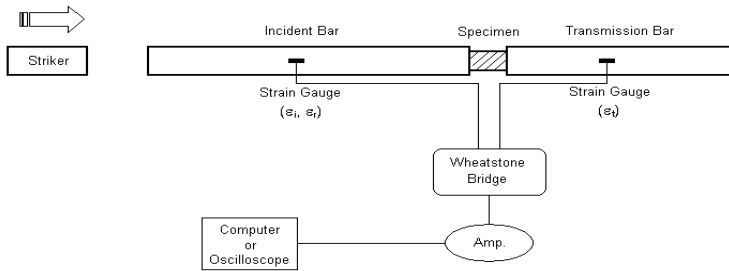
A very hard, brittle, silvery-white transition metal of the platinum family, iridium is the second-densest element (after osmium) and is the most corrosion-resistant metal, even at temperatures as high as 2000 C.



DOP-26 Iridium Alloy (developed by ORNL)

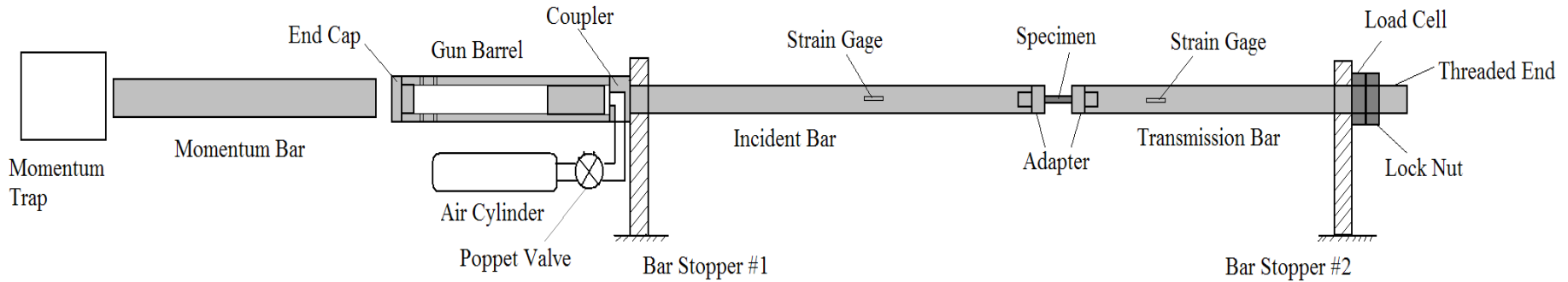
- *By weight:*
 - *0.3% tungsten to enhance weldability*
 - *60-ppm (parts per million) thorium to increase ductility*
 - *50-ppm aluminum*
- *Unique properties*
 - *High-melting point*
 - *Good high-temperature strength*
 - *Good oxidation resistance*
 - *Compatibility with the fuel and graphitic heat-source components*
 - *High impact ductility at high temperatures*

Kolsky Bar (Split Hopkinson Bar) Techniques



$$\dot{\epsilon} = \frac{u_1 - u_2}{l_0} = \frac{C_b}{l_0} (\epsilon_i - \epsilon_r - \epsilon_t) \quad \Rightarrow \quad \epsilon = \int_0^t \dot{\epsilon}(\tau) d\tau$$

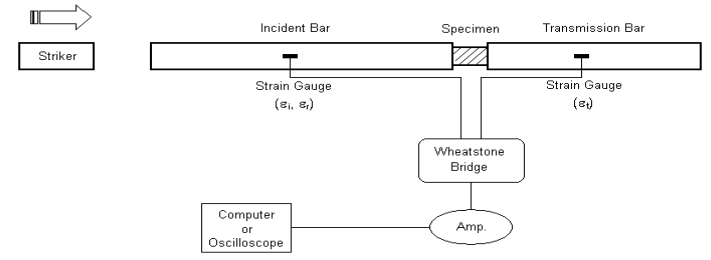
$$\sigma = \frac{F_1 + F_2}{2A_0} = \frac{E_b A_b}{2A_0} (\epsilon_i + \epsilon_r + \epsilon_t) \quad \Rightarrow \quad \sigma \sim \epsilon$$



High-Temperature Kolsky Bar Principles

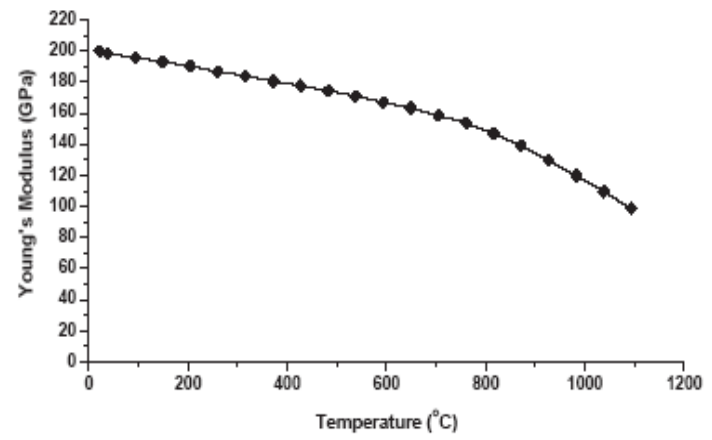
$$\dot{\epsilon} = \frac{u_1 - u_2}{l_0} = \frac{C_b}{l_0} (\epsilon_i - \epsilon_r - \epsilon_t) \implies \epsilon = \int_0^t \dot{\epsilon}(\tau) d\tau$$

$$\sigma = \frac{F_1 + F_2}{2A_0} = \frac{E_b A_b}{2A_0} (\epsilon_i + \epsilon_r + \epsilon_t) \implies \sigma \sim \epsilon$$

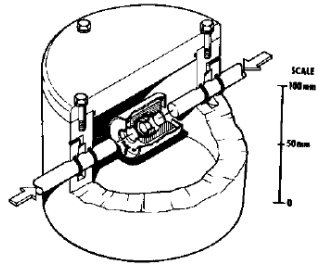


- Avoid “hot” pressure bars
 - Heat specimen individually
 - Hot Specimen/Cold Bars
 - Heat transfer
 - Specimen temperature drops
 - Bar temperature increases – thermal gradient in the bars

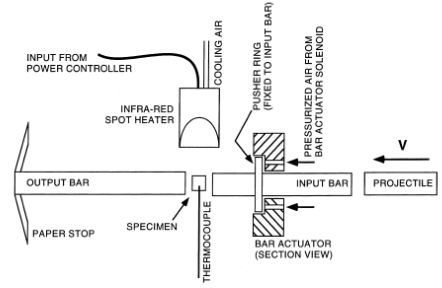
Cold Contact Time (CCT) is the time during which the “hot” specimen stays in contact with the “cold” pressure bars until being dynamically loaded



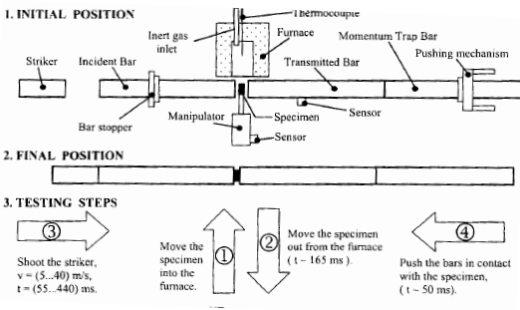
High-Temperature Kolsky Compression Bar



Follansbee et al. @LANL

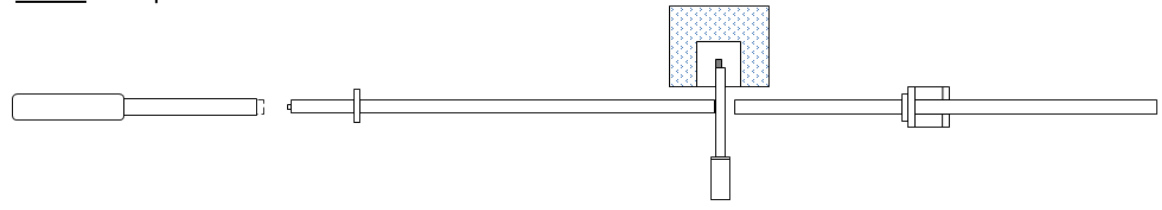


Ramesh, et al. @ JHU

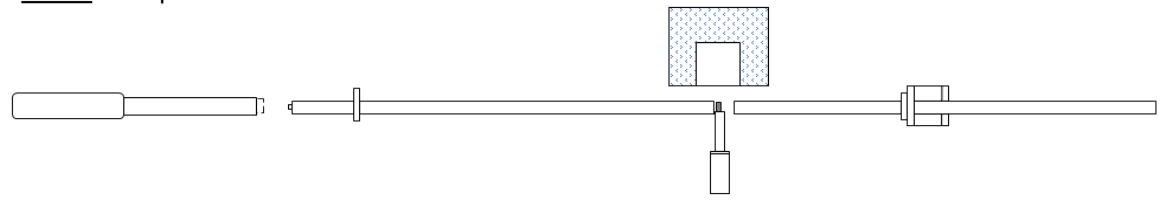


Kuokkala et al. @ TUT, FINLAND

STEP 1: Sample moved to furnace



STEP 2: Sample removed from furnace



STEP 3: Sample is engaged

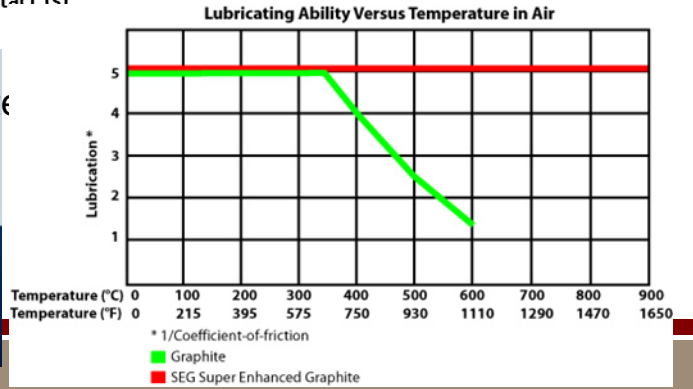
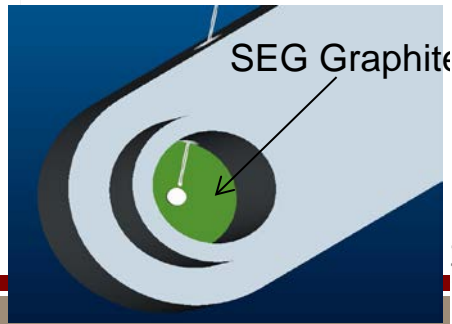
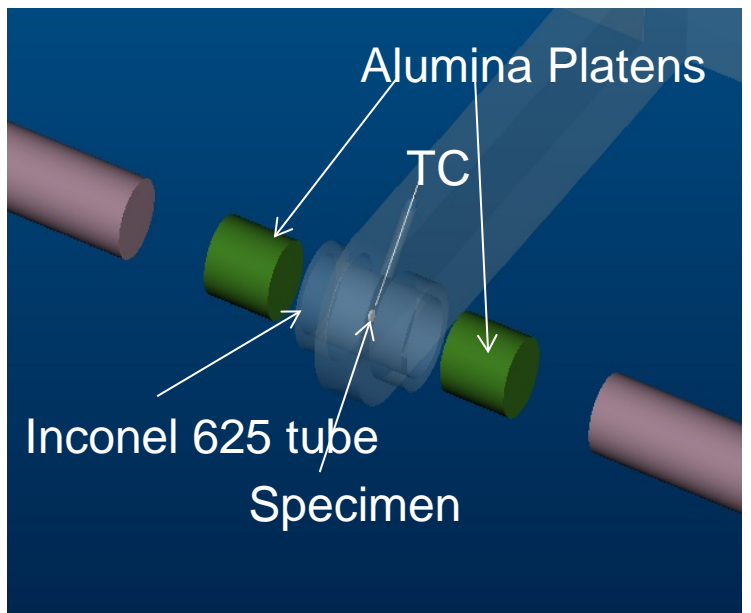
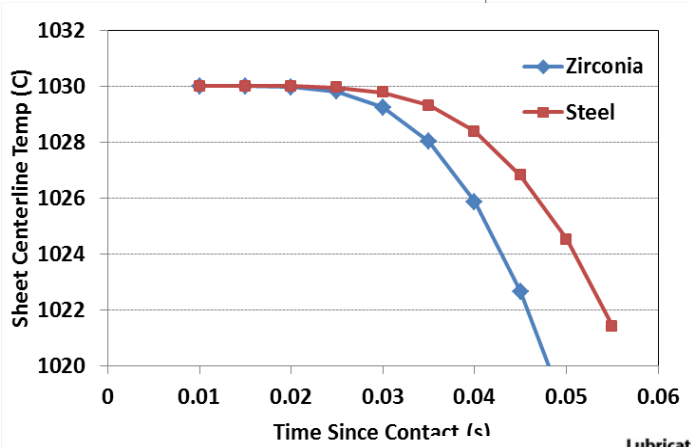
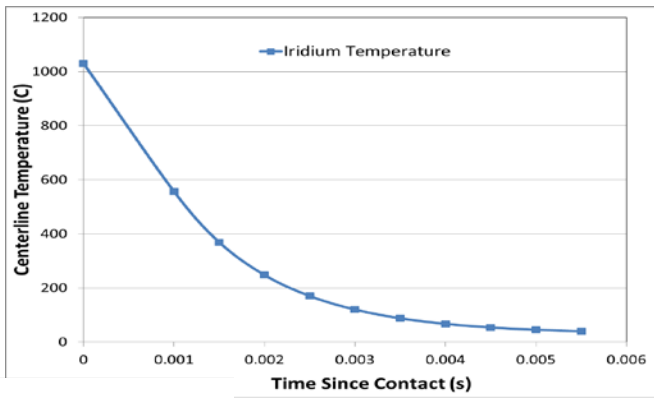


STEP 4: Striker is fired

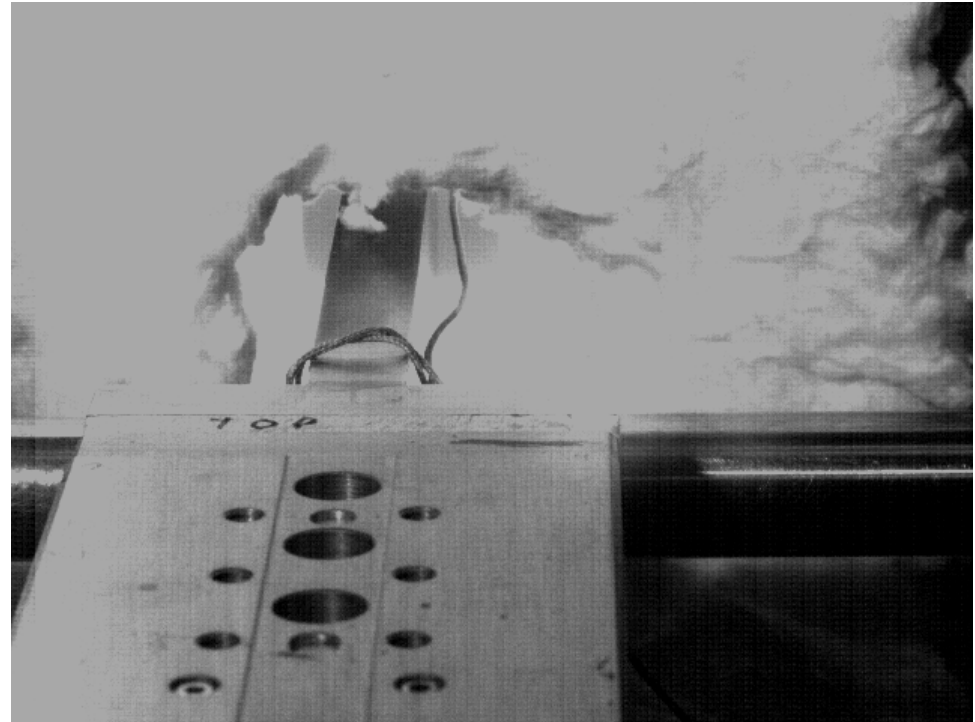
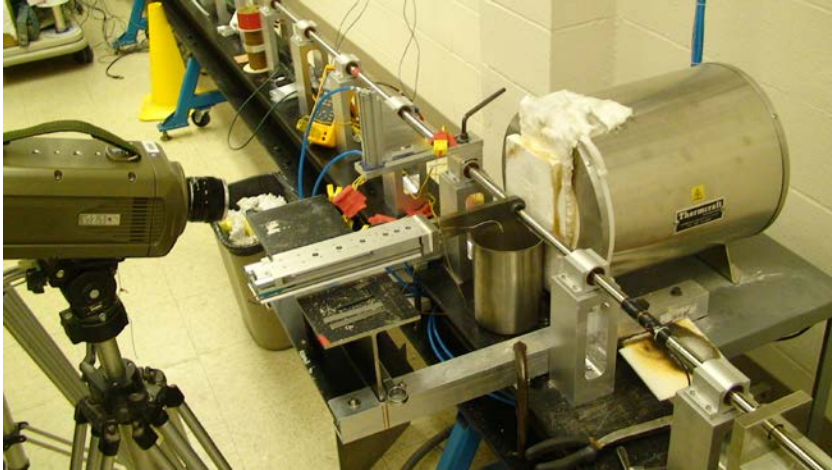


Additional Challenges for High-Temperature Kolsky Bar Testing of Iridium

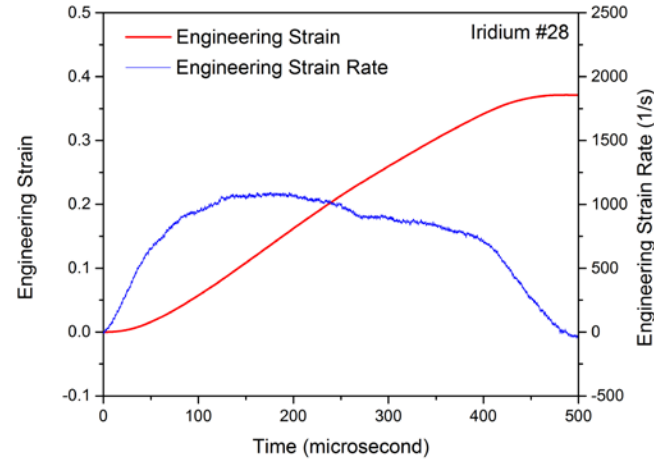
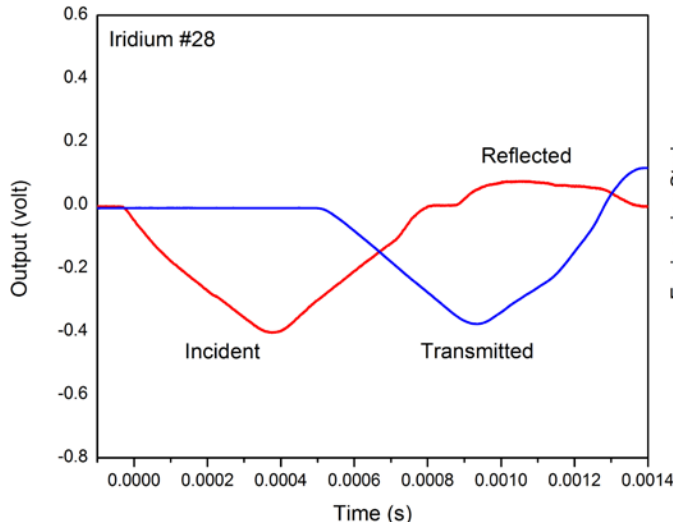
- Small/Thin Iridium Specimen
 - Temperature drops very quickly when the specimen starts in contact with cold pressure bars
 - High strength at high temperature
 - High-Temperature Lubrication



Compression Test Setup and Procedure

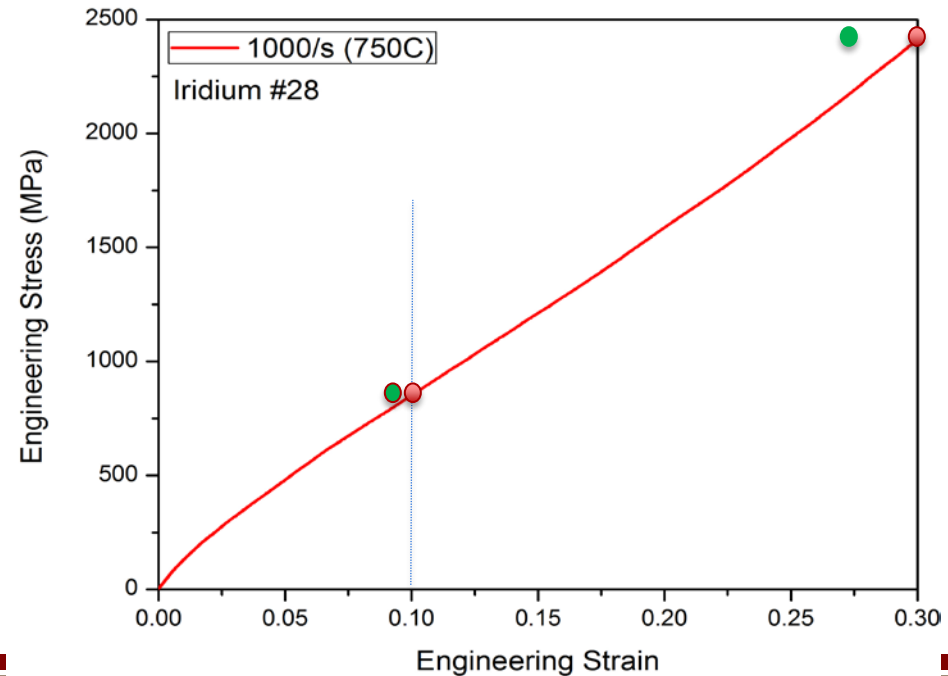
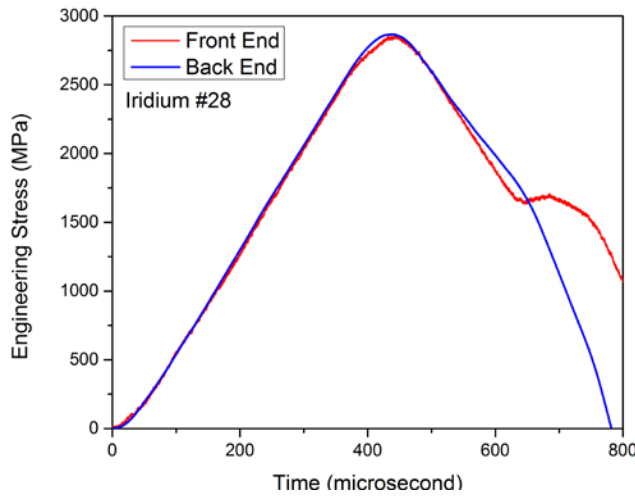


Compression Test at 1000 s⁻¹/750C



$$\dot{\epsilon} = \frac{u_1 - u_2}{l_0} = \frac{C_0}{l_0} (\epsilon_i - \epsilon_r - \epsilon_t)$$

$$\epsilon = \int_0^t \dot{\epsilon}(\tau) d\tau$$

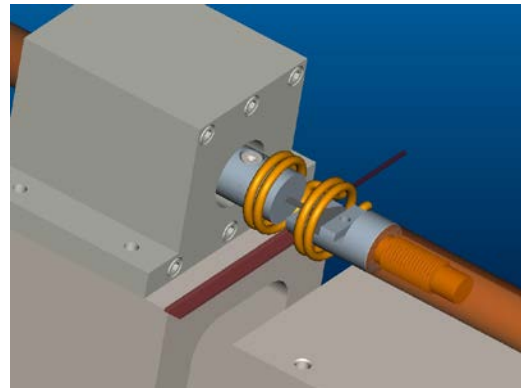
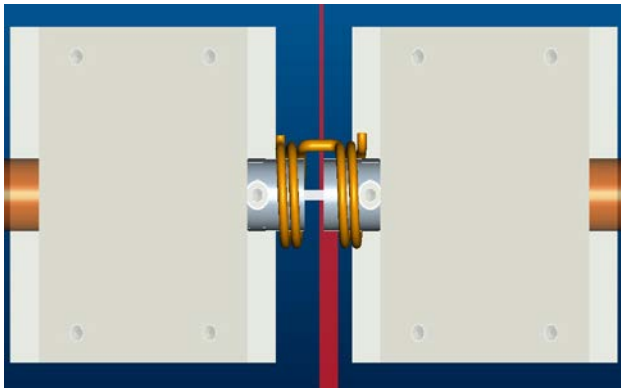
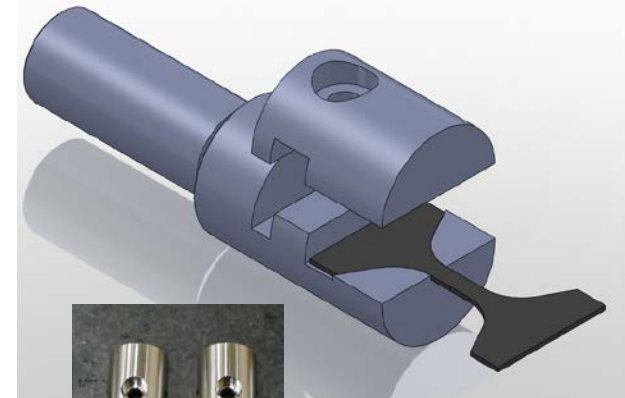
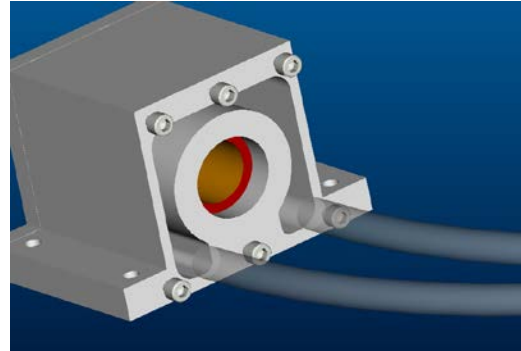
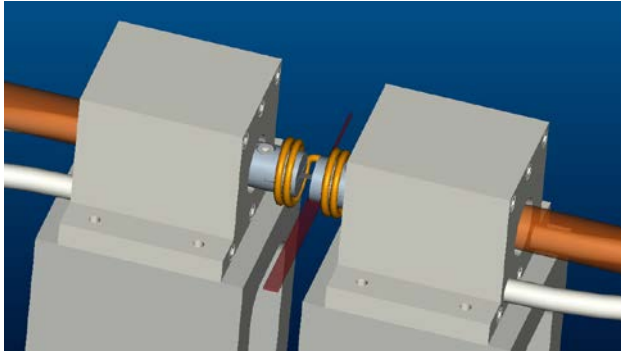
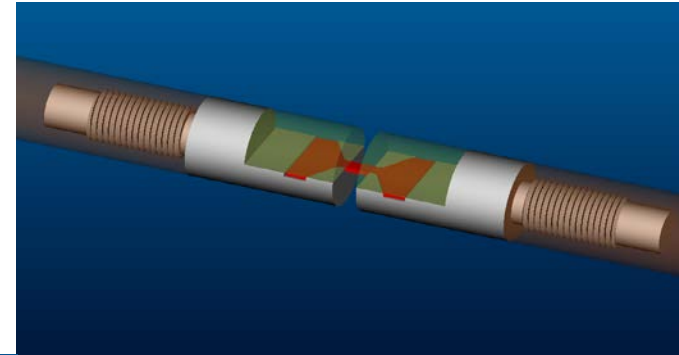


$$\sigma_1 = \frac{A_b}{A_0} E_b (\epsilon_i + \epsilon_r)$$

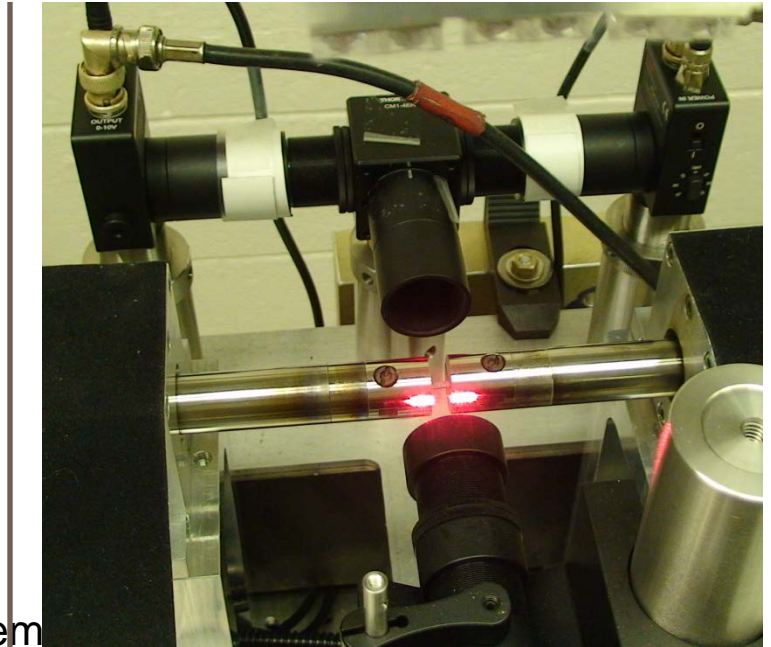
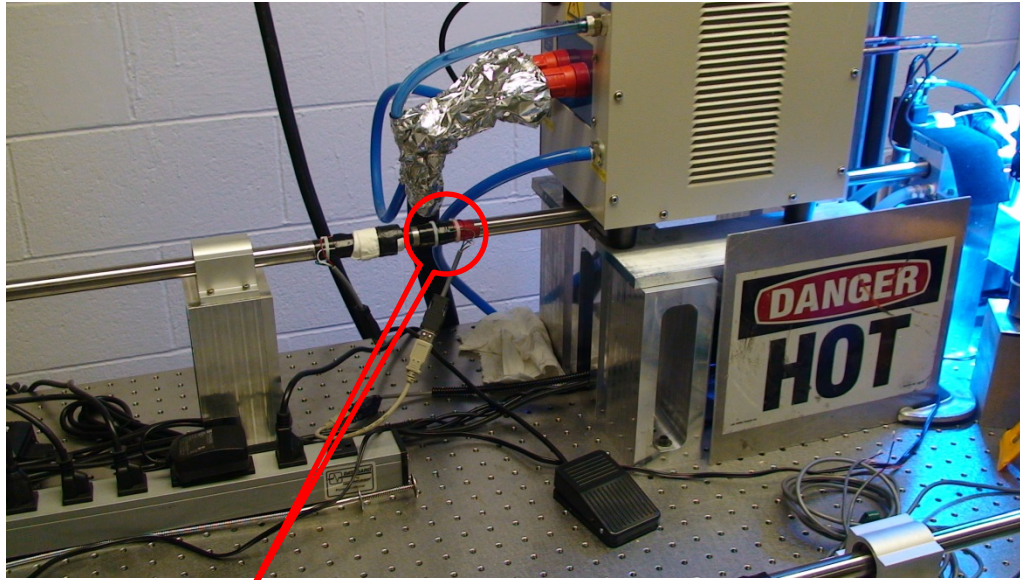
$$\sigma_2 = \frac{A_b}{A_0} E_b \epsilon_t$$

Tests

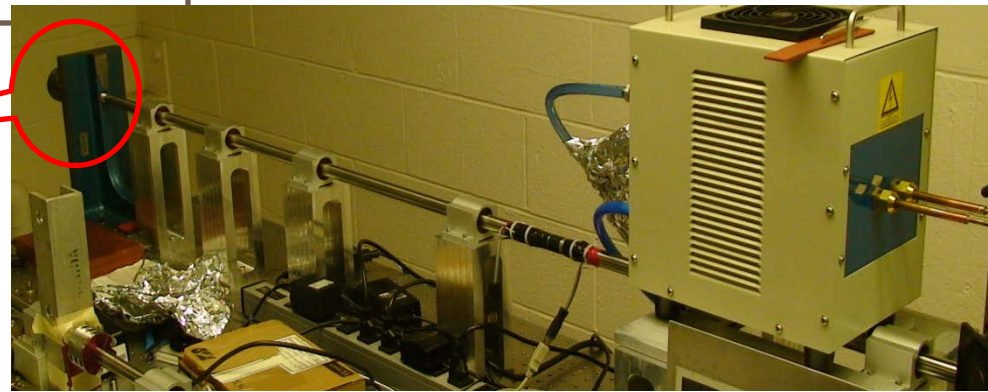
- Current high-temperature Hopkinson compression techniques are not applicable to tensile tests
- How?



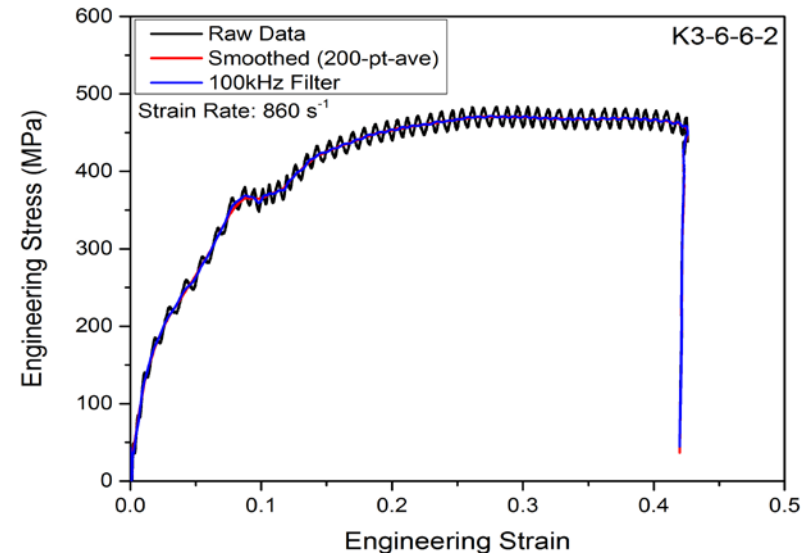
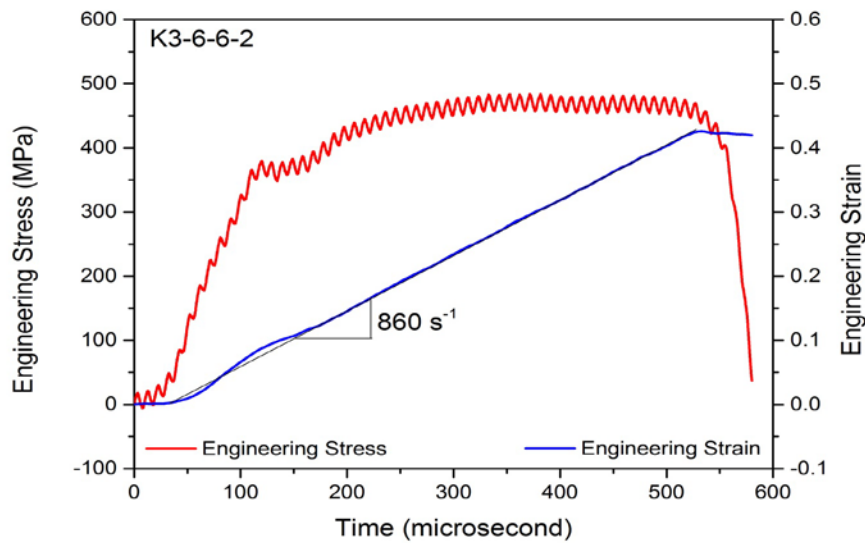
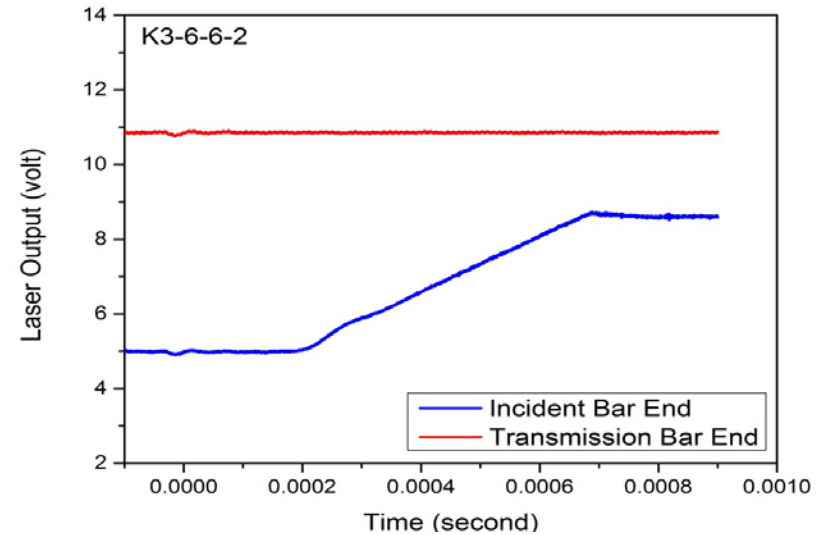
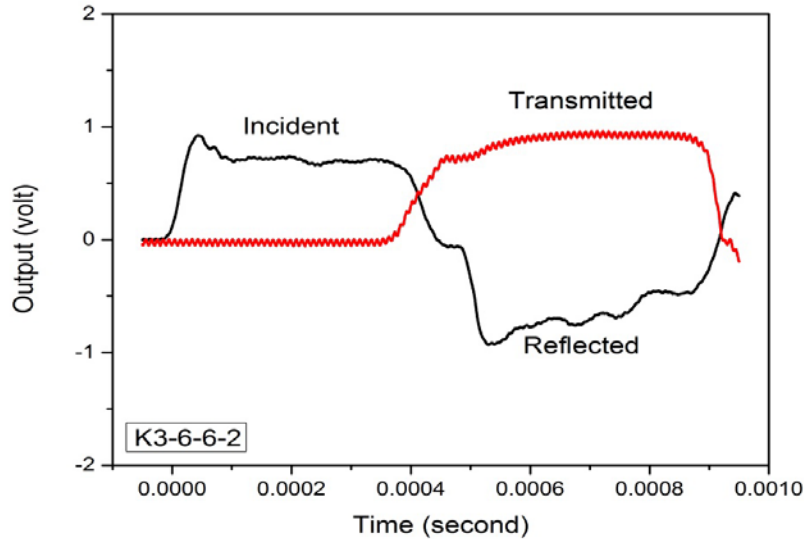
Stress and Strain Measurements



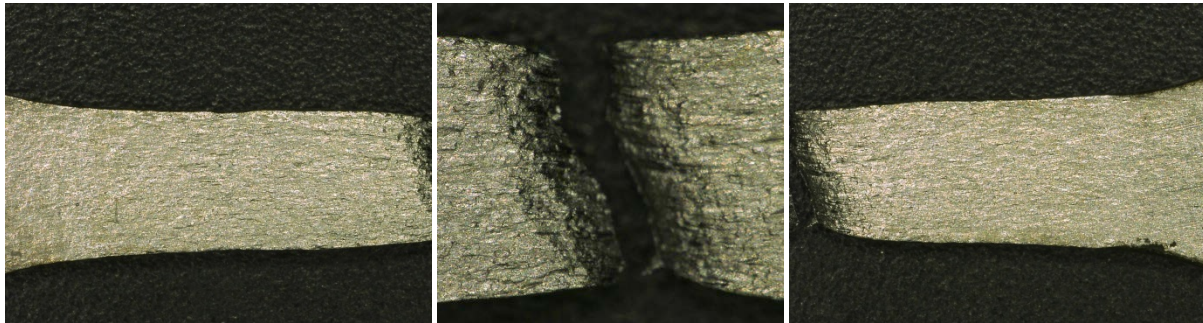
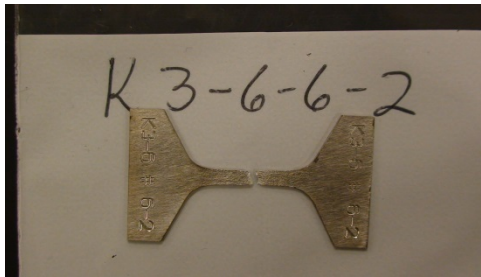
Semiconductor strain gages – specimen stress measurement
(GF: 139 vs. 2 for regular foil strain gage)



Typical Dynamic High-Temperature Tensile Test

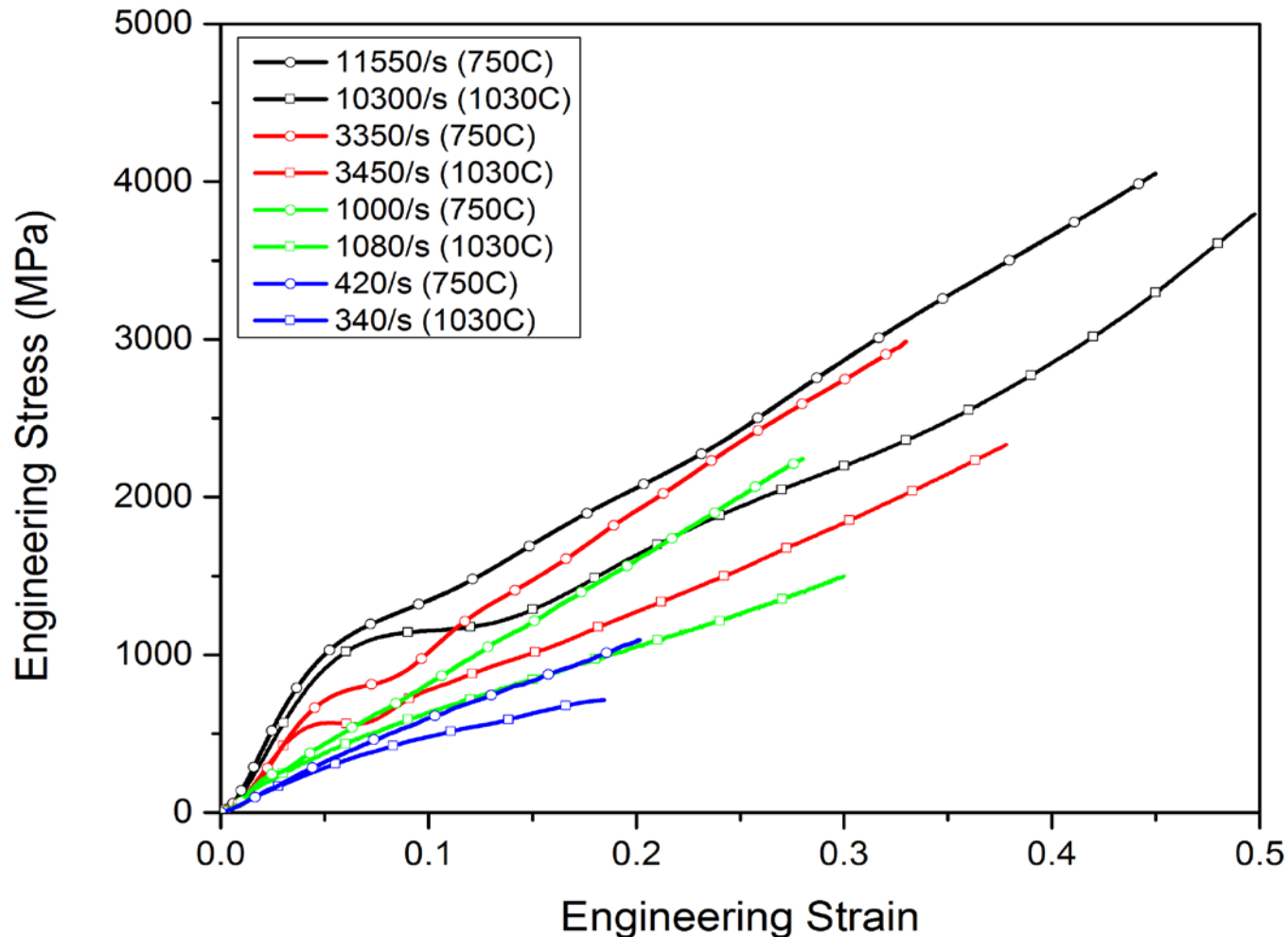


Specimen During and After Dynamic High-Temperature Test

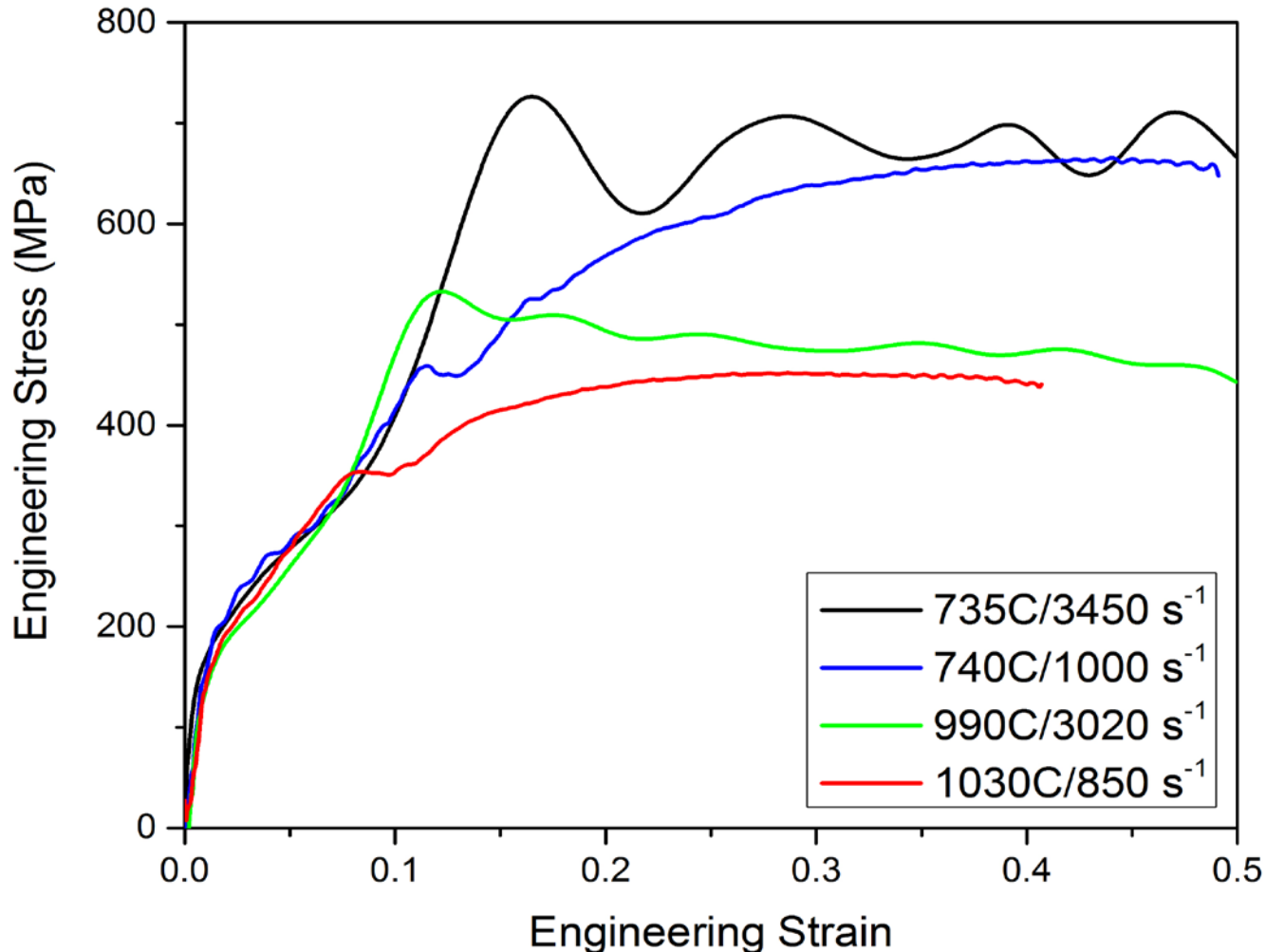


		K3-6-6-2	
Initial Measurements		After Measurements	
(in.)	(mm)		(mm)
0.03590	0.9119	*	1.3406
0.03495	0.8877		Break
0.03495	0.8877	*	1.3467
0.03495	0.8877		1.3606
0.03485	0.8852		1.2579
0.03505	0.8903		
** One or both indentations were difficult to detect			
Measurement value is suspect			
Average			
0.03511	0.89175		
		3.5725	5.3058 0.485

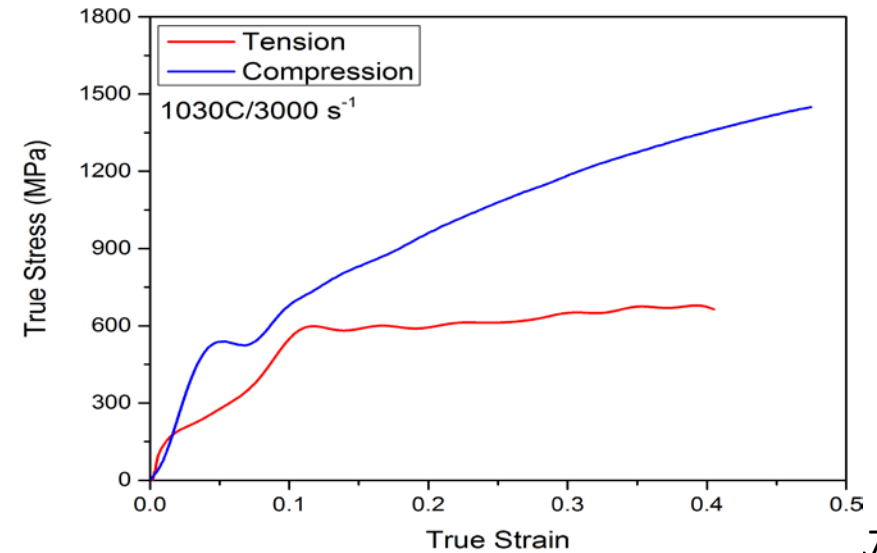
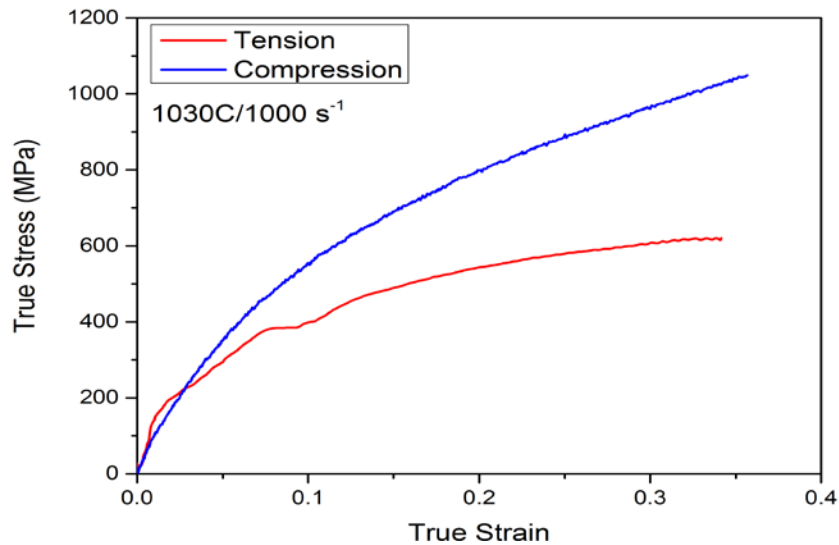
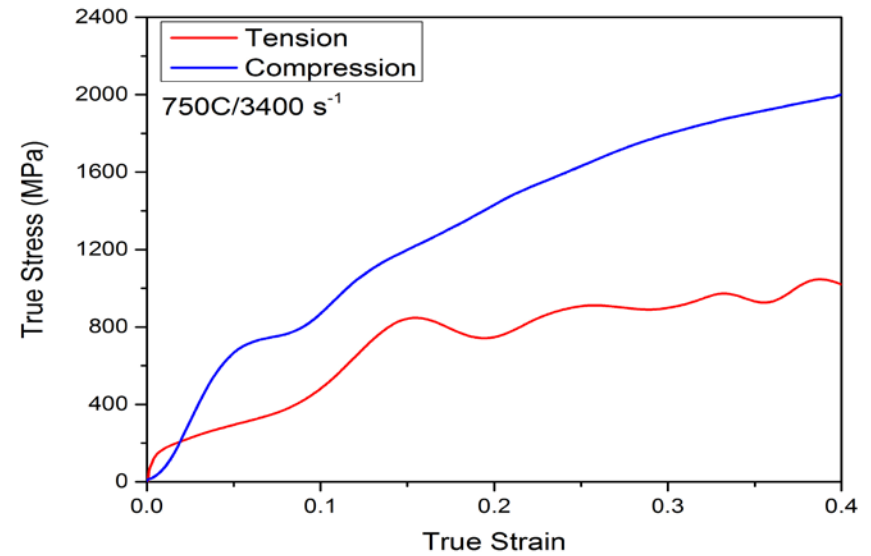
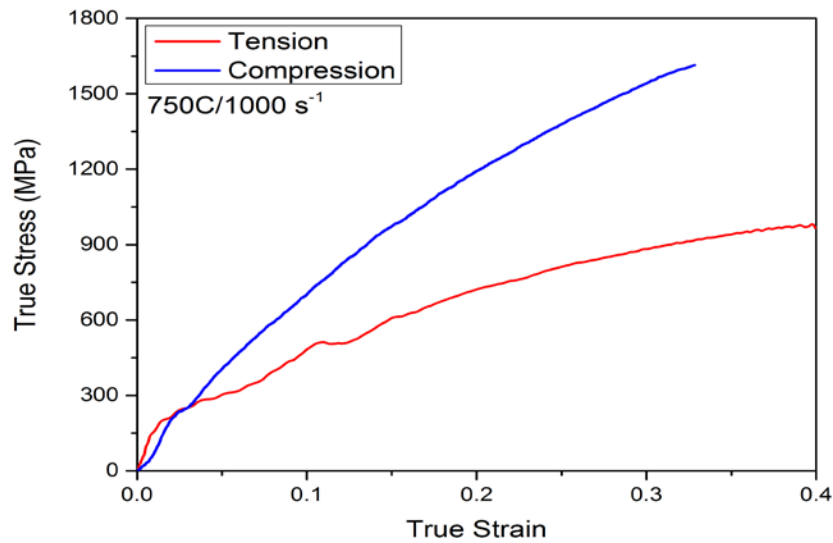
Engineering Compressive Stress-Strain Curves at Different Strain Rates and Temperatures



Engineering Tensile Stress-Strain Curves at Different Strain Rates and Temperatures



Tension vs Compression



Summary

- Kolsky bar (split Hopkinson bar) techniques have been properly modified to characterize Iridium in compression and tension at high temperatures
- DOP-26 iridium alloy has been dynamically characterized in compression and tension at different strain rates and temperatures
- The DOP-26 iridium has shown significant strain rate and temperature effects
 - *Flow stress increases with increasing strain rate but decreases with increasing temperature*

Acknowledgments

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